

PATENT NUMBER and ISSUE DATE

U.S. **UTILITY** Patent Application

APPL NUM 10016633	FILING DATE 10/30/2001	CLASS 216	SUBCLASS	GAU 1743	EXAMINER Tran 13				
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**APPLICANTS: Peiter Martin; Marx Eckhard; Mautz Karl;									
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**CONTINUING DATA VERIFIED									
** FOREIGN APPLICATIONS VERIFIED:									
TORLIGN AFFLICATIONS VERIFIED.									
PG-PUB DO	NOT PUBLISH 🖵		RESCIN	1D 🗀		<u> </u>			
Foreign priority di	imed		on L a		ATTORNEY DOCKET NO	_			
35 USC 119 conditions met □ yes □ no Verified and Acknowledged Examiners's initials					SC0142WD				
FITLE: Wafer scribing method and wafer scribing device									

NOTICE OF ALLOWANCE MAILED			CLAIMS ALLOWED					
		Assistant Examiner	Total Claims		Print Claim for O.G			
ISSUE FEE			DRAWING					
Amount Due	Date Paid	7	Sheets Drwg.	Figs.Drwg.	Print Fig.			
		Primary Examiner						
TERMINAL		PREPARED FOR ISSUE	Application Examiner					
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